



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

LUFFEL, Robert, W., et al.

Serial No. 10/051,573

Filing Date: January 17, 2002

For: LOW PROFILE SUPPORT SYSTEM
FOR DEVICE RACK-MOUNTING

Examiner: Tran, Khoa, H.

Art Unit: 3634

Conf. No.: 1003

Atty. Dkt.: 10001582-5

AMENDMENT UNDER 37 C.F.R. §§ 1.111 & 1.121

To: The Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

In response to the office action, paper number 3, dated May 23, 2002, please amend the above-identified patent application as follows:

In the Specification:

Please replace the paragraph on page 4, lines 1-13 with the following rewritten paragraph:

--A rack-mount storage system according to one embodiment of the present invention may comprise an equipment cabinet that defines at least one device opening therein. A first device sized to be received by the first device opening defines a first mounting pathway therein. The first device has a chassis that is sized to receive at least one component of the first device and that also defines at least a portion of the first mounting pathway. A support spar sized to be received by the first mounting pathway and being sized to engage said equipment cabinet and extend substantially between first and second sides of